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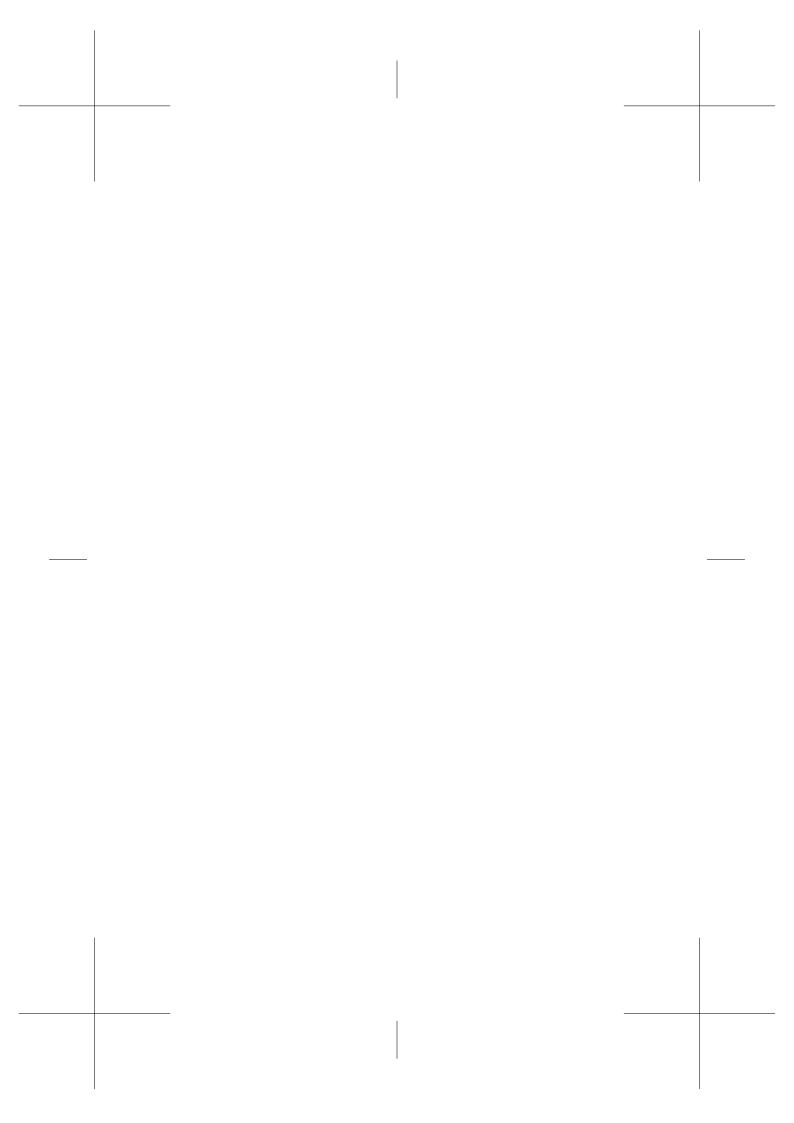
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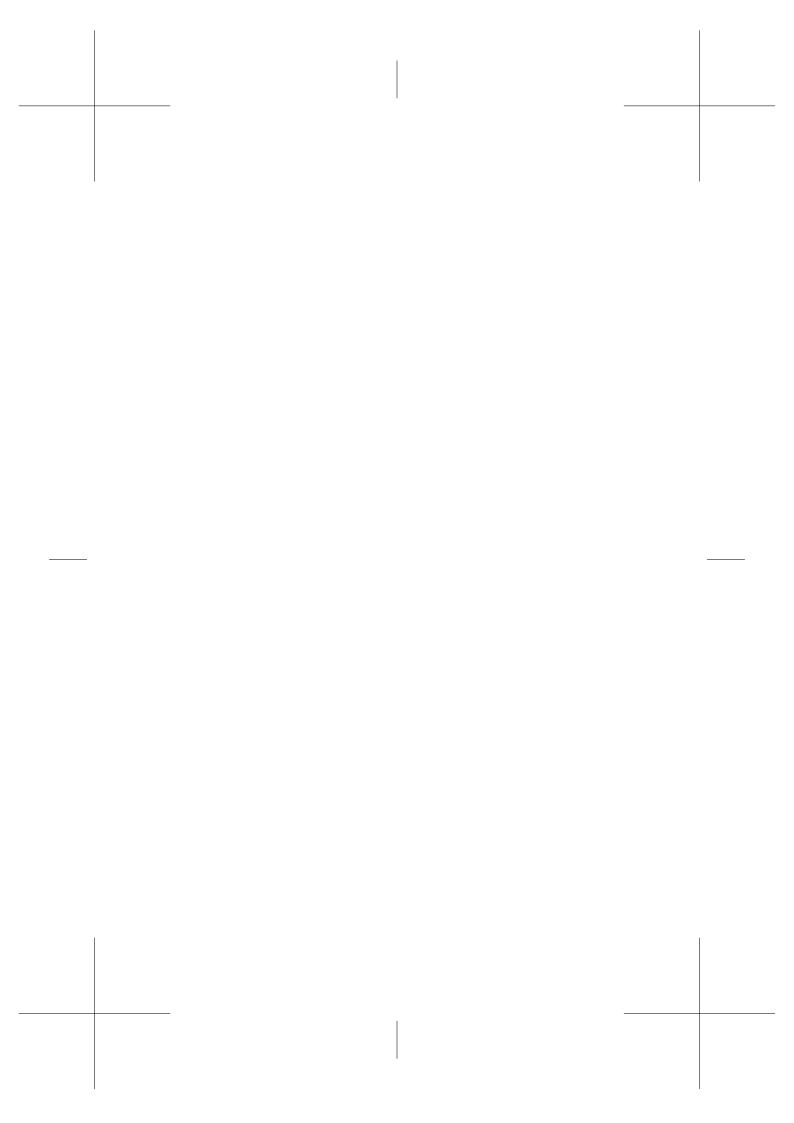








To everyone,



Special Thanks

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Put all your thanks here ...

Your Name Dec. 2013

Some quotes

Author

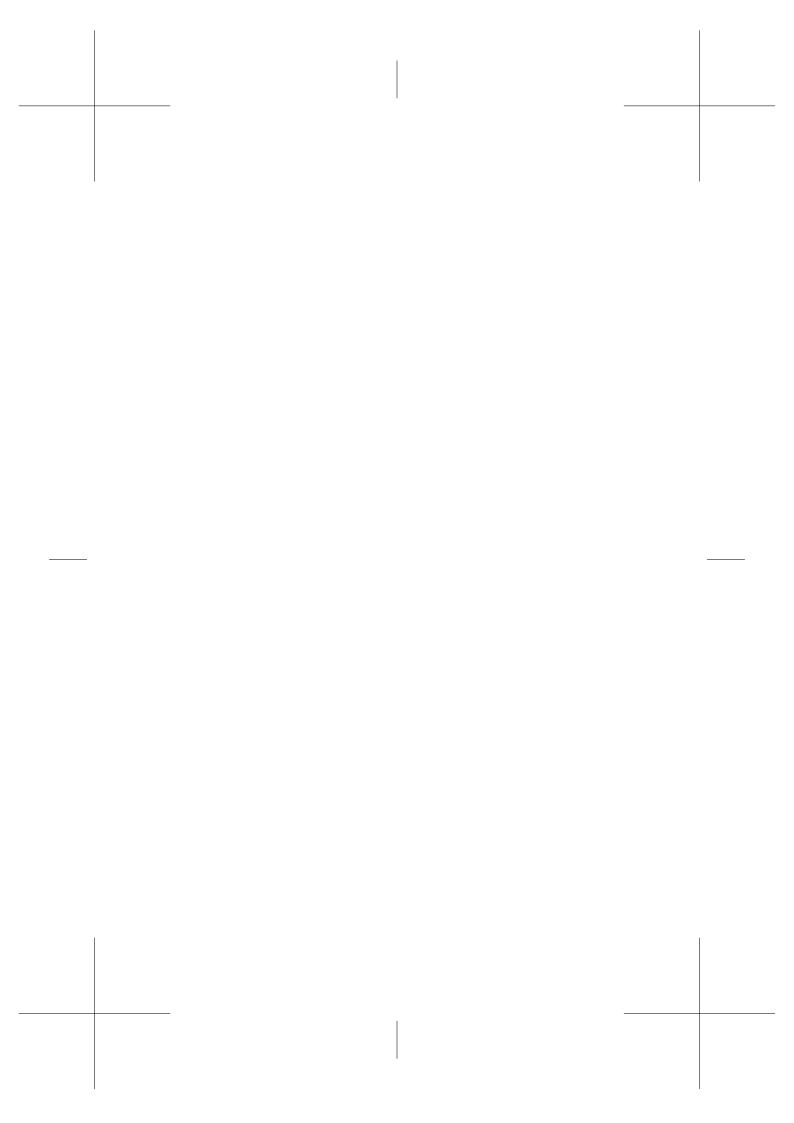


Table of Contents

	Thanks Word vii				
	List of Selected Figures				
	List of Selected Tables	X			
	Dutch Summary xii				
	English Summary xiii				
	Glossary xiv				
1	General Overview 1				
	1.1 First Section 2				
	1.2 References 4				
2	Another Chapter 5				
	2.1 First Section 6				
Α	An appendix 7				
В	Another Appendix 8				

List of Selected Figures

- 1.1 The evolution of MEMS technology over time from 1960 till2000.
- 1.2 The evolution of MEMS technology over time from 1960 till 2000. $\frac{2}{}$
- 1.3 The evolution of MEMS technology over time from 1960 till 2000.

List of Selected Tables	

Samenvatting

Dutch Summary ...

Summary

English Summary ...

Glossary

AC Alternative Current

CNT Carbon Nano Tube

DC Direct Current

DMD Digital Micromirror Device

FCB Flexible Circuit Board

IC Integrated Circuit

LED Light Emitting Diode

MEMS MicroElectroMechanical Systems

MT Multi Track

NC Normally ClosedNO Normally Open

PCB Printed Circuit Board PDMS Poly-dimethyl-siloxane

PI Polyimide

SEM Scanning Electron Microscope

Silicone Polyl-dimethly-siloxane

SMI Stretchable Molded Interconnect

ST Single Track



General Overview

A quote can be placed here if you like \dots .

Author

OUTLINE OF THIS CHAPTER

An overview of the chapter in a few lines \dots .

2 CHAPTER 1: GENERAL OVERVIEW

Fig. 1.1. The evolution of MEMS technology over time from 1960 till 2000. The major enabling technologies are shown in red. The picture is adopted from a presentaion by ...



Fig. 1.2. (a) The evolution of MEMS technology over time from 1960 till 2000. (b) The major enabling technologies are shown in red. The picture is adopted from a presentaion by ...





(a) First

(b) Second

1.1 First Section

The text of this section goes here



Fig. 1.3. The evolution of MEMS technology over time from 1960 till 2000. The major enabling technologies are shown in red. The picture is adopted from a presentaion by ...

Here another figure is placed. If the caption is not placed correctly compile the document again [1]. Fig. 1.1 on the facing page is a sample image.

4 CHAPTER 1: GENERAL OVERVIEW

Here the references of this chapter will be printed [2].

1.2 References

- 1. A. Jahanshahi, P. Salvo, and J. Vanfleteren, "Pdms selective bonding for the fabrication of biocompatible all polymer NC microvalves", *Microelectromechanical Systems, Journal of*, vol. 99, 2013, (To be published). [Online] (cited on p. 3).
- **2. A. Jahanshahi**, M. Gonzalez, J. van den Brand, F. Bossuyt, T. Vervust, *et al.*, "Stretchable circuits with horseshoe shaped conductors embedded in elastic polymers", *Japanese Journal of Applied Physics*, vol. 52, 05DA18, 2013. [Online] (cited on p. 4).

Stupidity includes hurrying before the right time and waiting until the opportunity has passed.

Enjoyments pass while consequences remain.

Ali ibn Abitalib

Another Chapter

A quote can be placed here if you like \dots .

Author

OUTLINE OF THIS CHAPTER

An overview of the chapter in a few lines \dots .

6 CHAPTER 2: ANOTHER CHAPTER

2.1 First Section

A few cross references:

A relative reference to a chapter is like chapter 1 on page 1.

A constant reference to a chapter is like chapter 1.

Chapter 1 on page 1 explains

Chapter 1 explains

Fig. 1.2(a) on page 2 shows

Fig. 1.2(a) shows

Stupidity includes hurrying before the right time and waiting until the opportunity has passed.

Enjoyments pass while consequences remain.

Ali ibn Abitalib



An appendix

The first appendix ...

B

Another Appendix

It was mentioned in chapter 1 ... Some codes are put here ...:

```
aiCont = AnalogInputCont(freq=100, numOfChannels=2)
aiCont.start('data.csv')
while True:
sleep(10)
l = len(aiCont.allData['time'])
aiCont.save()
print 'Samples Read:{}'.format(l)
aiCont.stop()
aiCont.clear()
```

